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Title of
Invention

ATOMIC LAYER DEPOSITION APPARATUS

Application Number: 09/917842

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First Named Applicant: Barry Chin

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US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
ASV	1	6630030	2003-10-07	Suntola et al.	B1		
	2	6579372	2003-06-17	Park	B2		
	3	6578287	2003-06-17	Aswad	B2		
	4	6572705	2003-06-03	Suntola et al.			
	5	6551406	2003-04-22	Kilpi			
	6	6511539	2003-01-28	Raaijmakers			
	7	6481945	2002-11-19	Hasper et al.			
	8	6478872	2002-11-12	Chae et al.			
	9	6447607	2002-09-10	Soininen et al.			
	10	6306216	2002-10-23	Kim et al.			

2001-10-23

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